



Research review

My research at the moment (12/01/06) Deivid Pugal







Previously completed tasks

- Model of movement of the cations.
 - $\frac{\partial C}{\partial t} + \nabla \cdot (-D\nabla C zuC\nabla V) = 0$
- Model of electric field change due to the ion movement
 - $\nabla^2 \phi = -\rho$







Bending model

- Assumption is that internal forces are due to charge imbalance
- No Euler beam theory
- Plane strain module, in Comsol, instead:
 - More suitable for finite element analysis
 - Dynamic instead of static solution.







Bending model - overview

Body forces in are defined as

$$-\nabla \cdot \sigma = \vec{F}$$

• Where σ is symmetric stress tensor and it is related to strain in the following way: $\sigma = D\varepsilon$

- Where again
$$\varepsilon = \begin{bmatrix} \varepsilon_{x} & \varepsilon_{xy} & \varepsilon_{xz} \\ \varepsilon_{xy} & \varepsilon_{y} & \varepsilon_{yz} \\ \varepsilon_{xz} & \varepsilon_{yz} & \varepsilon_{z} \end{bmatrix} \quad \varepsilon_{i} = \frac{\partial u_{i}}{\partial x_{i}} \quad \varepsilon_{ij} = \frac{1}{2} \left(\frac{\partial u_{i}}{\partial x_{j}} + \frac{\partial u_{j}}{\partial x_{i}} \right)$$

And D is elacticity matrix (inverse D is flexibility matrix).
 Includes variables such as *Poisson's ratio* and *Young's modulus*





Bending model - Rayleigh damping

- For transient analysis, we also have to consider damping!
- Comsol uses Rayleigh damping. Motion of the system:

$$m\frac{d^{2}u}{dt^{2}} + \xi \frac{du}{dt} + ku = f(t)$$
$$\xi = \alpha m + \beta k$$

- So the damping parameter ξ is expressed in terms of mass m and stiffness k
 - In my model: $\alpha = 1 \left[\frac{1}{s} \right], \beta = 0.05[s]$







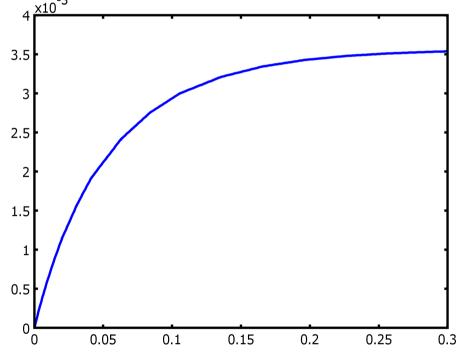
Bending model - forces

Force in each point of IPMC is defined as:

$$A \cdot (c_{Na} - c_{SO})$$

Displacement in time:

Value of y-displacement at (0.01,0)



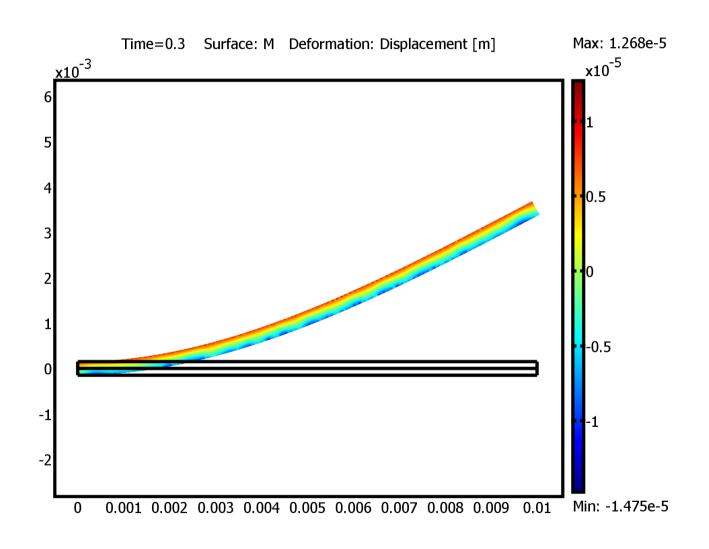








Bending model - an illustration









Electrochemical oscillation

- Electrochemical oscillations occur due to poisoning of Pt surface with CO, OH
- HCHO poisons the surface with CO.
- First, introducing the diffusion layer (for HCHO diffusion)
 - An article suggested thickness of the diffusion layer about 0.3mm
 - It means that if chemical reactions occur at the one end of the layer, then there is still const. concentration of reacting species at the other end.





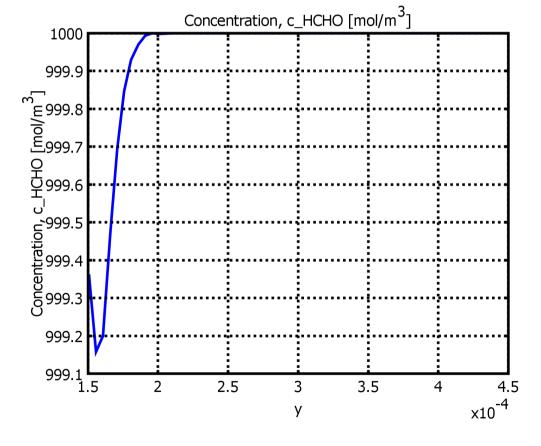




Electrochemical oscillation - conc. change

 Concentration change near platinum sufrace due to electrochemical reactions - must be considered in

model!









Equations - on surface of patinum electrode

 Basically, I use slight modification of equations from Doyeon's PhD thesis.

$$\begin{aligned} & \theta_{CO}^{\cdot} = & R \Big| k_2 \cdot (1 - \theta_{CO} - \theta_{OH}) - k_4 \cdot \theta_{CO} \cdot \theta_{OH} \\ & \theta_{OH}^{\cdot} = & k_3 \cdot (1 - \theta_{CO} - \theta_{OH}) - k_3 \cdot \theta_{OH} - k_4 \cdot \theta_{CO} \cdot \theta_{OH} \\ & \dot{E} = & I_{th} + \underbrace{(I - I_{th}) \cdot R \cdot sgn(c_{HCHO} - c_{HCHO2M})}_{CHCHO} - & j \cdot (k_1 \cdot (1 - \theta_{OH} - \theta_{CO}) + k_4 \cdot \theta_{CO} \cdot \theta_{OH}) \end{aligned}$$

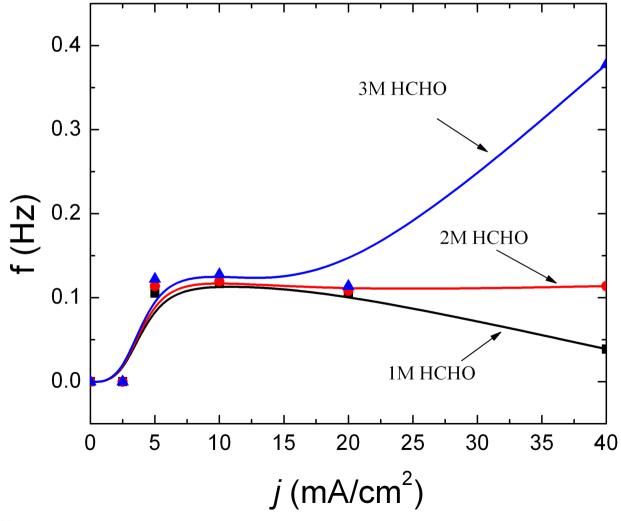
$$R = \frac{C_{HCHO}}{C_{HCHO2M}}$$

- Doyeon's model worked for 2M solution of HCHO
- This model also takes account concentration and applied constant current in range 10mA to 30mA





Electrochemical oscillations





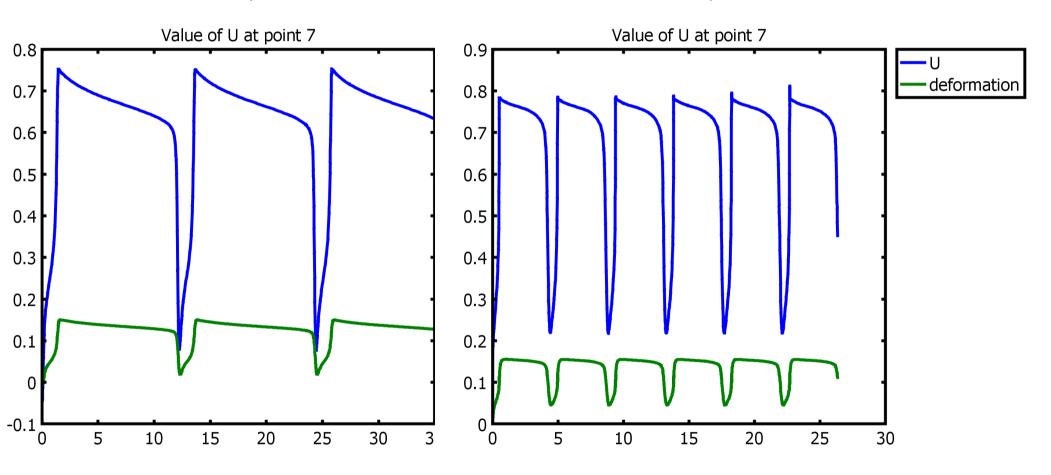




Displacement and voltage oscillations

1M HCHO, 25mA/cm2

3M HCHO, 25mA/cm2









Further goals

- Check all units and numbers. Specially everything related to diffusion layer.
- Better physical justification for addons to Doyeon's equations

